

PATENT RECEIVED
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In re: Chung et al. Group Art Unit: 2814
Serial No.: 10/047,706 Confirmation No.: 3888
Filed: January 15, 2002
For: SEMICONDUCTOR CAPACITORS HAVING TANTALUM OXIDE
LAYERS AND METHODS FOR MANUFACTURING THE SAME

Commissioner for Patents
Washington, DC 20231

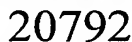
Sir:

The documents listed on the attached PTO-1449 were cited in the Notice to Submit Response of corresponding Korean Application No. 10-2001-0003165. Each document listed on the attached PTO-1449 was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement. A copy of each document, including the Examination Report, is enclosed. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

These items are cited herein because they were cited in the Notice to Submit Response in the corresponding Korean application. The Examiner may wish to consider the notations on the Notice to Submit Response itself regarding the relevance of each item. It is requested that these references be considered by the Examiner and officially made of record in accordance with the provisions of 37 CFR 1.97 and Section 609 of the MPEP.

Respectfully submitted,

Mitchell S. Bigel
Registration No. 29,614



PATENT TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on October 30, 2002.

Susan E. Freedman

Susan E. Freedman
Date of Signature: October 30, 2002